



648.41969CX1

AF/JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: G. SAITO, et al.

Serial No.: 10/658,393

Filed: September 10, 2003

For: METHOD FOR MANUFACTURING SEMICONDUCTOR  
DEVICE

Art Unit: 2823

Examiner: Fernando L. Toledo

Confirmation No. 2265

**AMENDMENT AFTER FINAL REJECTION**

**Mail Stop: AF Amendment – No fee**

Commissioner For Patents

P.O. Box 1450

Alexandria, VA 22313-1450

April 26, 2005

Sir:

In response to the final Office Action mailed January 26, 2005, please amend the above-identified application as listed in the following, and as set forth on the following pages:

AMENDMENTS TO THE CLAIMS; and

REMARKS are included following the amendments.